

220158US-2X DIV

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF: :
MASATAKA HASEGAWA ET AL : ATTN: APPLICATION DIVISION
SERIAL NO: NEW U.S. APPLICATION :
FILED: HEREWITH :
FOR: DIAMOND SEMICONDUCTOR AND
METHOD FOR THE FABRICATION
THEREOF

PRELIMINARY AMENDMENT

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

Prior to a first examination on the merits, please amend the above-identified
application as follows:

IN THE CLAIMS

Please cancel claims 1 and 2 without prejudice.

REMARKS

Favorable consideration of this application, as presently amended, is respectfully
requested.


The present application is a divisional of copending parent U.S. application serial no.
09/621,360. In that parent application Claims 3-6 were withdrawn as directed to a non-

electd invention. The present new Divisional application is submitted to further prosecute those claims 3-6 withdrawn in the parent of the present application. Thus, by the present preliminary amendment claims 1 and 2 are canceled so that claims 3-6 are pending.

The present application is believed to be in condition for a full and thorough examination on the merits. An early and favorable consideration of the present application is hereby respectfully requested.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.



Gregory J. Maier
Attorney of Record
Registration No. 25,599
Surinder Sachar
Registration No. 34,423



22850

(703) 413-3000
Fax #: (703) 413-2220
SNS/js

I:\atty\SNS\220158US-PR.wpd

220158US-2X DIV

Marked-Up Copy Serial No: <u>New Div</u> Amendment Filed on: <u>Herewith</u>
--

IN THE CLAIMS

--Claims 1 and 2 (Canceled).--